



Application No. 10/643,751
Paper Dated November 19, 2003
Attorney Docket No. 116-031357

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/643,751
Applicant : KENTARO YAMAGUCHI ET AL.
Filed : August 19, 2003
Title : ELECTROSPRAY MASS SPECTROMETER AND ION
SOURCE
Group Art Unit : Not Yet Assigned

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450


CLAIM FOR PRIORITY UNDER 35 U.S.C. § 119

Sir:

Applicants claim priority to Japanese Patent Application Nos. 2002-237793 and 2003-190067 which correspond to the above-identified United States patent application and which were filed in the Japanese Patent Office on August 19, 2002 and July 2, 2003, respectively. Certified copies of the priority documents will follow. The priority benefits provided by Section 119 of the Patent Act of 1952 are claimed for the above application.

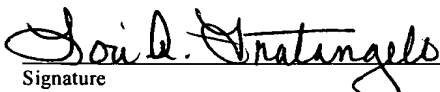
Respectfully submitted,

WEBB ZIESENHEIM LOGSDON
ORKIN & HANSON, P.C.

By 
David C. Hanson, Reg. No. 23,024
Attorney for Applicants
700 Koppers Building
436 Seventh Avenue
Pittsburgh, PA 15219-1818
Telephone: 412-471-8815
Facsimile: 412-471-4094
E-Mail: webblaw@webblaw.com

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 19, 2003.

Lori A. Fratangelo
(Name of Person Mailing Paper)


Signature

11/19/03
Date